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HAYNES AND BOONE

Attorney Docket No.: 22397.305 Customer No.: 27683

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No.: 22397.305 In re application of: Toda et al. 5 S Serial No.: n/a Group Art Unit: n/a \$ ŝ Herewith Filed: Examiner: n/a For: Method and System for Making A Micromachine Device with a Gas

Commissioner for Patents Washington, D.C. 20231

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Permeable Enclosure

## FOWER OF ATTORNEY FOR PATENT APPLICATION

As a representative of the Assignee, Ball Semiconductor, Inc., a Texas corporation, I hereby appoint the following attorneys and/or agents to prosecute this application and transact all business in the Patent and Trademark Office connected therewith.

David M. O'Dell (Reg. No. 42,044); David L. McCombs (Reg. No. 32,271); Michael J. Balconi-Lamica (Reg. No. 34,291); Jeffrey M. Becker (Reg. No. 35,442); J.R. Bell (Reg. No. 26,528); Theodore Baroody (Reg. No. 45,417); Timothy F. Bliss (Reg. No. P-50925); L. Howard Chen (Reg. No. 46,615); Randall E. Colson (Reg. No. 40,566); Michael A. Davis, Jr. (Reg. No. 35,488); Ruben C. DeLeon (Reg. No. 37,812); Brian J. Hubbard (Reg. No. 45,873); Rita M. Irani (Reg. No. 31,028); Mark P. Kahler (Reg. No. 29,178); Warren B. Kice (Reg. No. 22,732); Christopher P. Kosh (Reg. No. 42,760); J. Andrew Lowes (Reg. No. 40,706); Todd Mattingly (Reg. No. 40,298); John Montgomery (Reg. No. 31,124); Bill R. Naifeh (Reg. No. 44,962); and Phillip B. Philbin (Reg. No. 35,979).

Please address all correspondence and telephone calls regarding this application to:

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HAYNES AND BOONE

Attorney Docket No.: 22397.305 Customer No.: 27683

The undersigned is the representative for the Assignee of the entire right, title, and interest in the patent application identified above. A copy of the assignment or other documents in the chain of title are attached.

The undersigned (whose title is supplied below) is authorized to act on behalf of the Assignee.

Ball Semiconductor, Inc.

JANUARY 18, 2002 Date

RALPH R. M/LLS
Printed Name

VICE PRESIDENT 9 CFO

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PATENT / DOCKET NO.: 22397.305 CUSTOMER NO. 27683

## INVENTOR'S DECLARATION FOR PATENT APPLICATION

As below named inventors, we hereby declare that:

Our residence, post office address and citizenship are as stated below next to our names;

We believe we are the original, first and sole joint inventors of the subject matter which is claimed and for which a patent is sought on the invention entitled

METHOD AND SYSTEM FOR MAKING A MICROMACHINE DEVICE WITH A GAS PERMEABLE ENCLOSURE				
the specifica	tion of which: (check one)			
_ <u>X</u>	is attached hereto.			
	was filed onunder Attorney's Docket Numberas Application Serial Noand was amended on	_		
We hereby s identified sp above.	tate that we have reviewed and understand the ecification, including the claims, as amended by	contents of the above any amendment referred to		
We acknowl of this applie	edge the duty to disclose information which is neation in accordance with 37 CFR 1.56.	naterial to the patentability		
We hereby declare that all statements made herein of our own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under 18 USC 1001 and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.				

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PATENT / DOCKET NO.: 22397.305 CUSTOMER NO. 27683

FULL NAME OF FIRST INVENTOR: Risaku Toda					
INVENTOR'S SIGNATURE: DATED: 1/19/02					
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